

*IPW***TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))**Docket No.
IOAP 4.1-1

In Re Application Of: **Anatoly L. Vikharev, Aleksey M. Gorbachev, Aleksandr G. Litvak, Juriy V. Bykov, Grigory G. Denisov, Oleg A. Ivanov and Vladimir A. Koldanov**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/526,800	03/07/2005	Kelly M. Stouffer	21036	1792	7409

Title: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

Address to:

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

37 CFR 1.97(b)

- The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

- The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

OR

the fee set forth in 37 CFR 1.17(p).

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Under 37 CFR 1.97(b) or 1.97(c)

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In Re Application of
Anatoly L. Vikharev, Aleksey M. Gorbachev, Aleksandr G. Litvak, Jurij V. Bykov, Grigory G. Denisov, Oleg A. Ivanov and Vladimir A. Koldanov

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/526,800	03/07/2005		21036	1764	7409

Title: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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(Date)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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G. Denisov, Oleg A. Ivanov and Vladimir A.
Koldanov

For : HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND
FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE
PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

**INFORMATION STATEMENT UNDER
RULE 1.98**

Enclosed is a copy of PCT International Application No. PCT/RU2003/000410 dated September 18, 2003, and the references cited. Translations of the Russian references are also enclosed. None of the references were considered as more than part of the general state of the art "A" in the PCT application.

Respectfully,


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